

	Type	Hits	Search Text	DBs	Time Stamp
30	BRS	125	(thin adj film adj (transistor transistors) TFT) and island same (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:16
31	BRS	1217	(thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) with semiconductor with (insulate insulator insulating insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:15
32	BRS	9	(thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) with semiconductor with (insulate insulator insulating insulation) and island with (sidewall spacer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:12
33	BRS	93	(thin adj film adj (transistor transistors) TFT) and island with (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:16
34	BRS	4	("6387737" "6459124").pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:07
35	BRS	537	(thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) with semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:56

	Type	Hits	Search Text	DBs	Time Stamp
36	BRS	35	(thin adj film adj (transistor transistors) TFT) and heat\$treating near5 (insulating insulator insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:52
37	BRS	426	(thin adj film adj (transistor transistors) TFT) and island and (etch etching etched) near5 semiconductor near5 (insulate insulator insulating insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:16
38	BRS	7326	(thin adj film adj (transistor transistors) TFT) and island	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:10
39	BRS	238	(thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) with semiconductor and island	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:56
40	BRS	112	(thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) near5 semiconductor and island	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:56
41	BRS	790	(thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation) and island	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:55

	Type	Hits	Search Text	DBs	Time Stamp
42	BRS	2354	(thin adj film adj (transistor transistors) TFT) and (heat baking bake baked heat\$treating) near5 (insulating insulator insulation)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:55
43	BRS	14	(thin adj film adj (transistor transistors) TFT) and heat\$treating with (insulating insulator insulation) with semiconductor and island	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:36
44	BRS	51	(thin adj film adj (transistor transistors) TFT) and heat\$treating with (insulating insulator insulation) with semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/09/01 14:36